Application/Control No. O9/666,271 Examiner Hai C Pham Applicant(s)/Patent Under Reexamination SEKIYA ET AL. Art Unit Page 1 of 1

Notice of References Cited

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,133,984 🗸	10-2000	Deguchi et al.	355/40
	В	US-6,052,141	04-2000	Takeuchi, Akihiko	347/246
	С	US-5,581,295	12-1996	Prowak, James R.	347/237
	D	US-5,687,002 /	11-1997	Itoh, Tetsuya	347/133
	E	US-			
	F	US-			
	G	US-			
	н	US-			
	1	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
•	0					
	Р					
	Q					
	R					
	S	_				
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	٧							
	w	•						
	х							

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.